

<b>Notice of References Cited</b>	Application/Control No. 10/559,847		Applicant(s)/Patent Under Reexamination CRIVELLO, JAMES V.	
	Examiner Bernard Dentz		Art Unit 1625	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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#### FOREIGN PATENT DOCUMENTS

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#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
*	U	Crivello et al, Radtech Conference Proceedings, p.432-445 (1990)			
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